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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6435**
Takahisa HAYASHI : Docket No. 2003_1559A
Serial No. 10/699,734 : Group Art Unit 2826
Filed November 4, 2003 : Examiner Victor A. Mandala

SEMICONDUCTOR DEVICE AND METHOD
OF MANUFACTURING THE SAME

RESPONSE

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of June 28, 2004, Applicant in the above-referenced U.S.
Patent application elects the invention of Group I, corresponding to claims 1-5.

An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

Takahisa HAYASHI

By: 

Joseph M. Gorski
Registration No. 46,500

for

Nils E. Pedersen
Registration No. 33,145
Attorney for Applicant

NEP/jmj
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
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